

<b>Notice of References Cited</b>	Application/Control No. 10/783,467		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Lynette T. Umez-Eronini		Art Unit 1765	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,534,361 B2	03-2003	Lee, Joo-Won	438/253
*	B	US-6,451,708 B1	09-2002	Ha, Dae-Won	438/738
*	C	US-6,426,256 B1	07-2002	Chen, Tung-Po	438/256
*	D	US-6,281,059 B1	08-2001	Cheng et al.	438/200
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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